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Docket No.: 8733.213.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jin JANG et al.

Customer No.: 30827

Application No.: 09/497,508

Confirmation No.: 7572

Filed: February 4, 2000

Art Unit: 2814

For: POLYCRYSTALLINE SILICON FILM
CONTAINING Ni

Examiner: Wai Sing Louie

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the non-final Office Action dated November 4, 2005, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.